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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/810,598	03/29/2004	Toshio Masuda	520.39649CX3	9708	
20457	7590 06/27/2006			EXAMINER	
ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET			KACKAR	KACKAR, RAM N	
SUITE 1800	***************************************		ART UNIT	PAPER NUMBER	
ARLINGTON, VA 22209-3873			1763		
			DATE MAILED: 06/27/2000	6	

Please find below and/or attached an Office communication concerning this application or proceeding.

	TA 19 11 A	T 2 - 11 - 17 3			
	Application No.	Applicant(s)			
Office Action Summany	10/810,598	MASUDA ET AL.			
Office Action Summary	Examiner	Art Unit			
	Ram N. Kackar	1763			
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPL' WHICHEVER IS LONGER, FROM THE MAILING D. Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be timwill apply and will expire SIX (6) MONTHS from a, cause the application to become ABANDONE	N. nely filed the mailing date of this communication. (D. (35 U.S.C. § 133).			
Status					
1)⊠ Responsive to communication(s) filed on 11 A	nril 2006				
_	s action is non-final.				
· <u> </u>	, <u> </u>				
closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims	, , , , , , , , , , , , , , , , , , ,				
4)⊠ Claim(s) <u>24-26 and 29-34</u> is/are pending in the application.					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.					
6)⊠ Claim(s) <u>24-26 and 29-34</u> is/are rejected.					
7) ☐ Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction and/o	r election requirement.				
Application Papers					
·· _					
9) The specification is objected to by the Examiner.					
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.  Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Ex					
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:	priority under 35 U.S.C. § 119(a)	-(d) or (f).			
1. Certified copies of the priority documents have been received.					
2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the priority documents have been received in Application No					
application from the International Bureau (PCT Rule 17.2(a)).					
* See the attached detailed Office action for a list of the certified copies not received.					
	or the contined copies not receive.	u.			
Attachment(s)					
Notice of References Cited (PTO-892)	4) Interview Summary (	(PTO-413)			
Paper No(s)/Mail Date  Notice of Draftsperson's Patent Drawing Review (PTO-948)  Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Notice of Informal Patent Application (PTO-152)					
Paper No(s)/Mail Date	6) Other:	atent Application (PTO-152)			

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#### **DETAILED ACTION**

## Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 4/11/2006 has been entered.

## Claim Rejections - 35 USC § 112

- 2. The following is a quotation of the first paragraph of 35 U.S.C. 112:
  - The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.
- 3. Claims 24-26 and 29-35 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention. In this instance the recitation of "electrical power is supplied to the plate for generating the plasma" in claim 24 and "electrical power is supplied to the plate" in claim 30 is considered new matter. The specification discloses as follows:

The antenna bias power supply 123 applies to the plate 115 the bias of a frequency of, for example, 100 kHz or several MHz to several tens of MHz through the disk formed conductor 111, thereby controlling the reaction on the surface of plate 115. In the present embodiment, the

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plate 115 is made of highly pure silicon. Aluminum is used as material for the disk formed conductor 111 and housing, and quartz is used for the dielectric 112 and dielectric ring 113.

From this description and Fig 1 it is clear that the power gets connected to the conductor plate 111, which is above plate 115. Plate 115 is made of pure silicon (semiconductor).

Regarding claims 26 and 29 the recitation of the plate being made of the conductive material is also considered new matter since the plate is disclosed made of pure silicon.

- 4. The following is a quotation of the second paragraph of 35 U.S.C. 112:
  - The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 5. Claims 24-26 and 29-35 are also rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention. In this instance "the optical transmitter being opposite to and almost in contact with a back surface of the plate" as in claim 24 and "end face is almost in contact with the back surface of the upper plate" in claim 30 is indefinite, since "almost in contact" in both these cases does not tell if it is in contact or there is a gap of known dimension. In the Fig 2, which shows the detail, it appears in contact.

#### Claim Rejections - 35 USC § 102

6. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an

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international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

7. Claims 24-26 and 29-35 are rejected under 35 U.S.C. 102(e) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Grimbergen et al (US 6390019).

Grimbergen et al disclose a process chamber (Fig 1-35) and disclose optical transmitter (135) with through holes to allow light for the sensor (Fig 1-160 or Fig 2-25) to pass through holes (145), which allow the light to reach the sensor and reduce the possibility of deposition on the phase of the optical transmitter (Col 8 lines 35-43). Grimbergen et al teach that the aspect ratio of through holes depends upon particular process (Col 10 line 65- Col 11 line 2) and could be 12 (Col 10 lines 1-9). Further in (Fig 3a) Grimbergen et al teach optical transmitter arranged in the ceiling and teach that the plate in the ceiling (55) could be an electrode (Col 7 lines 44-50). Thus Grimbergen et al teach plasma chambers of different configuration where optical transmitter could be attached to ceiling through electrode as in Fig 3a and through shower head plate as in Fig 2 and still another arrangement as in Fig 6 showing that the placement of optical transmitter is possible in any mode of plasma generation.

Therefore it would have been obvious for one of ordinary skill in the art at the time of invention to have through holes in front of optical transmitter in order to have a longer use before cleaning or replacement by reducing the possibility of unwanted deposition.

## Response to Amendment

Applicant's arguments filed 4/11/2006 have been fully considered but they are not persuasive.

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Applicant's arguments regarding Moslehi are moot in view of new grounds of rejection.

Regarding the issue of the optical transmitter at the back of the plate with a gap, this issue is addressed in the 35 USC § 112 rejection.

### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Ram Kackar

Primary Examiner AU 1763

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